

<b>Notice of References Cited</b>	Application/Control No. 10/785,985	Applicant(s)/Patent Under Reexamination CHIU EH, CHUANG CHUN	
	Examiner Stacy B. Chen	Art Unit 1648	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,585,365	12-1996	Hayashi et al.	514/54
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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